# $H_2O$  incorporation in the phosphorene/a-SiO<sub>2</sub> interface: A first-principles study

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Based on first-principles calculations, we investigate the energetic stability and the electronic properties of (i) a single layer phosphorene (SLP) adsorbed on the amorphous  $SiO<sub>2</sub>$  surface (SLP/a- $\text{SiO}_2$ ), and (ii) the further incorporation of water molecules at the phosphorene/a- $\text{SiO}_2$  interface. In (i), we find that the phosphorene sheet bonds to a- $SiO<sub>2</sub>$  through van der Waals interactions, even upon the presence of oxygen vacancy on the surface. The  $SLP/a-SiO<sub>2</sub>$  system presents a type-I band alignment, with the valence (conduction) band maximum (minimum) of the phosphorene lying within the energy gap of the a- $SiO<sub>2</sub>$  substrate. The structural, and the surface-potential corrugations promote the formation of electron-rich and -poor regions on the phosphorene sheet and at the SLP/a-SiO<sub>2</sub> interface. Such charge density puddles have been strengthened by the presence of oxygen vacancies in a-SiO<sub>2</sub>. In (ii), due to the amorphous structure of the surface, we have considered a number of plausible geometries of  $H_2O$  embedded in the  $SLP/a-SiO_2$  interface. There is an energetic preference to the formation of hydroxyl (OH) groups on the  $a-SiO<sub>2</sub>$  surface. Meanwhile, upon the presence of oxygenated water or interstitial oxygen in the phosphorene sheet, we find the formation of metastable OH bonded to the phosphorene, and the formation of energetically stable P–O–Si chemical bonds at the  $SLP/a-SiO<sub>2</sub>$  interface. Further x-ray absorption spectra (XAS) simulations have been done, aiming to provide additional structural/electronic informations of the oxygen atoms forming hydroxyl groups or P–O–Si chemical bonds at the interface region.

## I. INTRODUCTION

Phosphorene is a two-dimensional (2D) material, consisting of a single-layer of the black phosphorus allotrope that, currently, has received tremendous attention. It presents unique properties, such as layer-controlled direct bandgap  $[1, 2]$  $[1, 2]$ , high-mobility  $[3]$ , and p-type semiconductor properties [\[4\]](#page-6-3). These properties make phosphorene a quite interesting 2D material for electronic applications [\[5–](#page-6-4)[9\]](#page-6-5).

There are two main methods to produce phosphorene, both based on the exfoliation processes down to a monolayer thickness, viz.: mechanical exfoliation [\[10](#page-6-6)[–12\]](#page-6-7) and liquid exfoliation [\[13](#page-6-8)[–15\]](#page-6-9). However, exfoliated phosphorus degrades when exposed in ambient conditions [\[16,](#page-6-10) [17\]](#page-6-11). Such a phosphorene degradation  $[11, 18]$  $[11, 18]$  is an irreversible process, ascribed to the presence of oxygen atoms, and water molecules. Indeed, phosphorene presents lower chemical stability due to the lone pairs of the surface P atoms, which leads it to be very reactive when exposed to air. In Ref. [\[19\]](#page-6-14) the authors have been shown that oxygen interstitial defect on phosphorene lead to increasing of hydrophilicity of the surface, which may play an important role in the surface degradation. Further studies have been done in an effort to understand the degradation of phosphorene upon the presence of  $O_2$  and/or  $H_2O$ molecules [\[11,](#page-6-12) [20–](#page-6-15)[22\]](#page-6-16), as well as some proposals to avoid it. For instance, phosphorene surface passivation through  $Al_2O_3$  coating  $[23-25]$ .

The degradation process of phosphorene is strongly correlated with its boundary conditions. In a recent experimental study, Wood et al. [\[22\]](#page-6-16) verified that the degradation of transistors, composed by few layers of phosphorene, can be suppressed upon the presence of a hydrophilic substrate  $(SiO<sub>2</sub>)$  and a coating layer of  $AIO<sub>x</sub>$ . Since  $SiO<sub>2</sub>$  surface is by far the most common substrate to buildup transistors, it is quite important to get a clear picture of the electronic interactions and the structural properties of (i) phosphorene adsorbed on the  $SiO<sub>2</sub>$  surface, as well as (ii) the role played the  $SiO<sub>2</sub>$  surface in the phosphorene degradation mediated by the presence of  $H_2O$  molecules.

In this work, we performed an atomistic study, based on first-principles calculations of (i) and (ii) described above. We have considered a single layer phosphorene (SLP) adsorbed on the amorphous  $SiO<sub>2</sub>$  surface (SLP/a- $SiO<sub>2</sub>$ ). In (i), we found that the SLP bonds to the a-

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 $SiO<sub>2</sub>$  surface mediated by van der Walls (vdW) interactions, even upon the presence of oxygen vacancies  $(V<sub>O</sub>)$ , which is the most common intrinsic defect in  $SiO<sub>2</sub>$ . The structural, and the surface-potential corrugations promote the formation of electron-rich and -poor regions on the phosphorene sheet, and at the phosphorene/a- $SiO<sub>2</sub>$ interface. Such charge density puddles are strengthened by the presence of oxygen vacancies in a- $SiO<sub>2</sub>$ . In (ii), we have considered a number of plausible configurations for the  $H_2O$  molecules embedded in the  $SLP/a-SiO_2$  interface. We find an energetic preference for the formation of hydroxyl  $(OH)$  groups bonded to the a-Si $O<sub>2</sub>$  surface, when compared with the SLP, even upon the presence of the interstitial oxygen adatoms in the SLP sheet. However, due to the amorphous character of the  $a-SiO<sub>2</sub>$  surface, depending on the local geometry at the  $SLP/a-SiO<sub>2</sub>$ interface region, we verified the formation of energetically stable P–O–Si structure bridging the SLP sheet and the a-SiO<sub>2</sub> surface. Finally, x-ray absorption spectra  $(XAS)$ simulations have been done, aiming to provide additional structural/electronic informations of the oxygen atoms forming hydroxyl groups or P–O–Si chemical bonds at the interface region.

## II. METHODOLOGY

The amorphous structure was generated through ab initio molecular dynamics (MD) simulations based on the density functional theory (DFT) approach, as implemented in the VASP code $[26-28]$  $[26-28]$ . In Ref.  $[29]$ , we present details on the generation procedure of amorphous  $SiO<sub>2</sub>$  bulk structure. For DFT calculatons, the generalized gradient approximation (GGA) for the exchangecorrelation potential is used. The ion-electron interaction is treated with the projected augmented wave (PAW)[\[30,](#page-6-22) [31\]](#page-6-23) method. The plane-wave cutoff energy for wave function is set to 500 eV and the brillouin zone was sampled at the Γ point. All atoms were allowed to relax until the atomic forces were smaller than  $0.025 \mathrm{eV/A}$ . In addition, a combination of optB88vdW [\[32,](#page-6-24) [33\]](#page-6-25) for geometry optimization and HSE06 [\[34\]](#page-6-26) for density of state (based on the optB88-vdW optimized structure) is used, which has been shown very reliable for single-layer phosphorene (SLP). The slab model contains three different atomic species with vacuum region of ca.  $15 \text{ Å}$ , so that the interaction between successive periodic images along to z-direction can be neglected. The optimized lattice parameter for single-layer phosphorene (SLP) was  $a =$ 4.38 Å and  $b = 3.31$  Å, in good agreement with previous theoretical and experimental results[\[4,](#page-6-3) [35\]](#page-6-27). In our calculations we used a 3×4 supercell size.

## III. RESULTS AND DISCUSSIONS

#### A.  $SLP/a-SiO<sub>2</sub>$  interface

Initially we examine the energetic stability of a SLP adsorbed on the defect-free amorphous  $SiO<sub>2</sub>$  surface  $(SLP/a-SiO<sub>2</sub>)$ . In Fig. [1\(](#page-2-0)a1) we present the structural model and the electronic charge transfers (which will be discussed below) of  $SLP/a-SiO<sub>2</sub>$ . The energetic stability of the SLP adsorbed on the  $SiO<sub>2</sub>$  surface was examined by the calculation of the adsorption energy  $(E^{\text{a}})$ , which can be written as,

$$
E^a = E[a\text{-SiO}_2] + E[\text{SLP}] - E[\text{SLP}/a\text{-SiO}_2].
$$

Where  $E[\text{SLP}]$  and  $E[a-\text{SiO}_2]$  are the total energies of the separated components, an isolated SLP, and the a-SiO<sub>2</sub> surface, respectively;  $E[\text{SLP}/a-\text{SiO}_2]$  is the total energy of the fully relaxed  $SLP/a-SiO<sub>2</sub>$  system. It was considered the adsorption of SLP on two different (amorphous)  $SiO<sub>2</sub>$  surfaces, where we found adsorption energies of 13.9 and  $11.3 \,\mathrm{eV} / \text{\AA}^2$ , and (averaged) vertical distances between the SLP and the  $a-SiO<sub>2</sub>$  surface of  $2.80$  and  $2.75$  Å. Thus, suggesting the absence of chemical bonds at the SLP–surface region. The SLP sheet is attached to the  $a-SiO<sub>2</sub>$  surface mediated by vdW interactions. Somewhat similar picture has been verified for other 2D systems adsorbed on  $a-SiO_2$ . For instance, we obtained  $E^{\text{a}}$  of 6.3 and  $15 \text{ meV}/\text{\AA}^2$  for graphene and  $MoS<sub>2</sub>$  on the a-SiO<sub>2</sub> surface, [\[36,](#page-7-0) [37\]](#page-7-1).

Due to the surface corrugation, SLP on  $a-SiO<sub>2</sub>$  may also present structural deformations, as observed for graphene on a-SiO<sub>2</sub> [\[38,](#page-7-2) [39\]](#page-7-3); giving rise to electron-rich and -poor regions (so called electron-hole puddles) on the graphene surface  $[40]$ . Indeed, due to corrugation of the (amorphous) surface potential, and the vertical distortion of  $\sim 0.08$  Å of the SLP adsorbed on a-SiO<sub>2</sub>, we also verify the formation of electron-hole puddles on the SLP surface, as well as electronic charge transfers at the  $SLP-a-SiO<sub>2</sub>$  interface region. Here, we map the total charge transfers  $(\Delta \rho)$  by comparing total charge density of the final system,  $SLP/a-SiO_2$  ( $\rho$ [SLP/a-SiO<sub>2</sub>]) with the ones of the isolated components,  $SLP$  ( $\rho$  $SLP$ ) and a-SiO<sub>2</sub> ( $\rho$ [a-SiO<sub>2</sub>]),

$$
\Delta \rho = \rho [\text{SLP}/\text{a-SiO}_2] - \rho [\text{SLP}] - \rho [\text{a-SiO}_2].
$$

Our result of  $\Delta \rho$  for a SLP on the pristine a-SiO<sub>2</sub> surface is presented in Fig.  $1(a1)$  $1(a1)$ . In Fig.  $1(a2)$  we present the planar average of  $\Delta \rho$  perpendicularly to the surface plane,  $\Delta \rho(z)$ . The electronic charge transfer is (i) not uniform on the surface plane, and (ii) mostly localized at the interface region, where we have both positive as negative values of  $\Delta \rho$ . In order to quantify the total charge transfers, we have used the Bader charge density analy- $\sin[41, 42]$  $\sin[41, 42]$ ; where we found that the total charge density of the SLP reduces by  $6.70 \times 10^{12} e/cm^2$ .



<span id="page-2-0"></span>FIG. 1. (a1) Structural model and the electronic charge transfers  $(\Delta \rho)$  of a single layer phosphorene adsorbed on the a-SiO<sub>2</sub> surface  $(SLP/a-SiO<sub>2</sub>)$ ; (a2) planar average of the net charge transfer perpendicularly to the  $SLP/a-SiO<sub>2</sub>$  interface. (b1) Structural model and the electronic charge tranfers of SLP/a- $SiO<sub>2</sub>$  upon the presence of an intrinsic defect on the surface, oxygen vacancy; (b2) planar average of the net charge transfer perpendicularly to the  $SLP/a-SiO<sub>2</sub>$  interface. Green regions indicate an increase of total charge density,  $\Delta \rho > 0$ , while blue regions indicate a decrease ( $\Delta \rho \langle 0 \rangle$ ). The P, O, Si and H atoms are represented by light purple, red and gray color spheres.

The SLP−SiO<sup>2</sup> interaction has been strengthened upon the presence of oxygen vacancies. We found that the adsorption energy increases to 16.6 meV/ $\AA^2$ , and there is a net charge transfer of  $1.06 \times 10^{13} e/cm^2$  $(0.19 e/V<sub>O</sub>$  defect), from the surface to the SLP. In Figs. [1\(](#page-2-0)b1) and 1(b2), we present our results of  $\Delta \rho$  and  $\Delta \rho(z)$ , respectively. It noticeable that the most of the charge density gain is localized on the lower zigzag chains of the phosphorene; somewhat similar picture has been verified for the the n-type doped graphene bilayers on

the Cu(111) surface  $[43]$ . It is worth noting the formation electron-rich ( $\Delta \rho > 0$ , green regions) and electron-poor  $(\Delta \rho < 0,$  blue regions) embedded in the phosphorene layer, Fig. [1\(](#page-2-0)b1), while  $\Delta \rho \approx 0$  in the SiO<sub>2</sub> surface. As verified for graphene on  $SiO<sub>2</sub>$  [\[36,](#page-7-0) [40\]](#page-7-4), those electron-rich and -poor regions, randomly distributed on the phosphorene layer, are ruled by the structural deformation of the adsorbed SLP, and the corrugation of the  $a-SiO<sub>2</sub>$  surface potential.

Focusing on the electronic properties, we calculate the energy positions of the valence band maximum (VBM), and conduction band minimum (CBM) of the isolated components, and the ones of the final system, SLP/a- $\text{SiO}_2$ , Fig. [2.](#page-3-0) The energy positions were aligned with respect to the vacuum level [\[44\]](#page-7-8). For the SLP we find an ionization potential of 5.3 eV, and an energy gap of 1.55 eV, which are in good agreement with recent theoretical studies  $[2, 45, 46]$  $[2, 45, 46]$  $[2, 45, 46]$  $[2, 45, 46]$ . Meanwhile, for the a-SiO<sub>2</sub> we find an energy gap of 6.15 eV, and an ionization potential of  $8.4 \text{ eV}$ . In Fig.  $2(a2)$  $2(a2)$  we present the density of states (DOS) (shaded region) and the projected density of states (PDOS) on the SLP (dashed lines) and  $SiO<sub>2</sub>$ (solid lines). The VBM and the CBM of the SLP are slightly perturbed (by about 0.1 meV) upon its interaction with the  $a-SiO<sub>2</sub>$  surface, being both localized within the energy gap of the  $a-SiO_2$ . In this case, the SLP- $a-$ SiO<sup>2</sup> interface presents a type-I band alignment, with valence band offset (VBO) and conduction band offset (CBO) of about 3.11 and 1.47 eV, respectively. Here we are not considering the contribution of the dipole effects, at the SLP−a-SiO<sup>2</sup> interface region, on the band VBM and CBM band alignment [\[47\]](#page-7-11).

A single oxygen vacancy on the  $a-SiO<sub>2</sub>$  surface gives rise to an occupied defect level within the energy gap of  $a-SiO<sub>2</sub>$ . Here, we find the an occupied defect level lying at VBM+1.60 eV [Fig.  $2(b1)$  $2(b1)$ ], in good agreement with previous theoretical work [\[48\]](#page-7-12). Upon the formation of  $SLP/a-SiO_2$ , the defect level is resonant with the VBM of the adsorbed SLP sheet, Figs.  $2(b1)$  $2(b1)$  and  $2(b2)$ ; meanwhile the energy positions of the VBM and CBM of SLP are weakly perturbed by the presence of the  $V_{\Omega}$  defect.

## B.  $H_2O$  at  $SLP/SiO_2$  interface

Here, initially we examine the energetic stability of water molecules adsorbed on the separated components, *viz.*: water on SLP  $(H_2O/SLP)$ , and on the amorphous a-SiO<sub>2</sub> surface  $(H_2O/a-SiO_2)$ . For the former system, we have considered two (energetically stable)  $H_2O/SLP$  configurations, Figs.  $3(a)$  $3(a)$  and  $3(b)$ ; both recently proposed in the literature [\[20,](#page-6-15) [21\]](#page-6-28). We found that those two structures are very close in energy, where we obtained  $H_2O$  adsorption energies of 0.18 and 0.21 eV/molecule, respectively. Our total energy results support the "two leg" geometry recently proposed by Wang *et al.* [\[21\]](#page-6-28). At the equilibrium geometry, the molecular structure of  $H_2O$  has been preserved, lying at 2.50 Å from the SLP surface.



<span id="page-3-0"></span>FIG. 2. Electronic energy levels of the valence band maximum (VBM) and the conduction band minimum (CBM) of the isolated components,  $SLP$  and  $a-SiO<sub>2</sub>$ , and the ones of the final system,  $SLP/a-SiO<sub>2</sub>$ , and the projected density of states (PDOS), of the pristine surface (a1-a2), and upon the presence of an oxygen vacancy (b1-b2).  $\varepsilon_0$  indicate the energy position of the (oxygen vacacy) defect level.

There are several studies addressing the adsorption of water molecules on silica surfaces. The subject becomes more complicated and interesting for amorphous surfaces, since we have a very large number of energetically metastable configurations of  $H_2O$  on a-SiO<sub>2</sub>. Here we have considered two different geometries, viz.: (i) a H2O molecule attached to the four-fold coordinated surface Si atom  $[H_2O/a-SiO_2$  in Fig[.3\(](#page-3-1)c), and (ii)  $H_2O$  dissociated geometry, giving rise to two hydroxyls, one composed by the oxygen and hydrogen atoms remnant from the adsorbed  $H<sub>2</sub>O$  molecule, and another composed by

a H atom, dissociated from the original  $H_2O$  molecule, bonded to the two-fold coordinate oxygen atom of the a-SiO<sub>2</sub> surface  $[OH/(OH)a-SiO<sub>2</sub>$  in Fig. [3\(](#page-3-1)d). In (i) we find an adsorption energy of 1.19 eV/molecule, with Si–O equilibrium bond length of  $1.82 \text{ Å}$  (close to the sum of the covalent radii of Si and O,  $1.83 \text{ Å}$ ), indicating the formation of chemical bond between the  $H_2O$  molecule and the a-SiO<sub>2</sub> surface. Our adsorption energy, and Si–O bond length results are in good agreement with the ones obtained by Zhao and Jing  $[49]$ , for H<sub>2</sub>O adsorbed on SiO<sub>2</sub> clusters. On the other hand, we find that once the  $H_2O$ molecule is adsorbed on the a-SiO<sub>2</sub> surface, the formation of hydroxyl groups  $[(ii)]$ ,  $H_2O/a-SiO_2 \rightarrow OH/(OH)a-SiO_2$ , is an exothermic process by 1.45 eV. Indeed, the formation of OH groups on  $a-SiO_2$  has been supported by other theoretical studies  $[50-52]$ , and it is in agreement with the experimental observation [\[53\]](#page-7-16). Those adsorption energy results allow us to confirm the hydrophilic character of the  $a-SiO<sub>2</sub>$  surface with respect to the SLP. In a recent experimental study, performed by Wood et al. [\[22\]](#page-6-16), the authors verified that the oxidation rate, of exfoliated black phosphorous, has been reduced by the presence of the (hydrophilic)  $SiO<sub>2</sub>$  surface.



<span id="page-3-1"></span>FIG. 3. Equilibrium geometries of the  $H_2O$  molecule adsorbed on the single layer phosphorene (a) and (c); and on the  $a-SiO<sub>2</sub>$ surface (b) and (d). The P, O, Si and H atoms are represented by light purple, red, gray and white color spheres.

Next we examine the presence of  $H_2O$  at the SLP−a- $SiO<sub>2</sub>$  interface region. Within our calculation approach, the interactions between the  $H_2O$  molecules are negligible; we are considering lateral distances of about  $13 \text{\AA}$ between the molecules, which corresponds to a planar concentration of  $5.6 \times 10^{13}/\text{cm}^2$ . At such a low coverage regime, the adsorption energy of SLP on the  $H_2O/a-SiO_2$ surface  $[\text{SLP/H}_2\text{O}/\text{a-SiO}_2$  in Fig. [4\(](#page-4-0)a)] is practically the same as that obtained without  $H_2O$  molecules. We have considered two  $SLP/H_2O/a-SiO_2$  configurations, where we found  $E^{\rm a}$  of 13.2 and 15.8 meV/ $\AA^2$ , and the vertical distance between the SLP and the  $a-SiO<sub>2</sub>$  surface increases to  $3.47 \text{ Å}$  (averaged value).

Similarly to the  $H_2O/a-SiO_2$  systems discussed above, the formation of hydroxyl groups even at the presence of the SLP layer,  $SLP/H_2O/a-SiO_2 \rightarrow SLP/OH/(OH)a$ - $\text{SiO}_2$  [Fig. [4\(](#page-4-0)b)], is an exothermic process; the total energy reduces by 1.23 eV. The presence of hydroxyl groups at the SLP−a-SiO<sup>2</sup> interface increases the corrugation of the SLP by  $0.14 \text{ Å}$ , in comparison with the SLP/a-SiO<sub>2</sub> system,  $0.08 \rightarrow 0.22$  Å, where the SLP lies at 2.50 Å from the  $(OH)/(OH)a-SiO<sub>2</sub>$  substrate (averaged values). Indeed, similar equilibrium geometry picture has been verified for graphene adsorbed on  $a$ -HfO<sub>2</sub>, intercalated by  $H<sub>2</sub>O$  molecules [\[54\]](#page-7-17).

In order to provide a more complete picture of water in  $SLP/a-SiO<sub>2</sub>$ , we have also considered the presence of oxygen, (i) as a interstitial defect attached to the SLP, and (ii) forming oxygenated  $H_2O$ , embedded between the phosphorene sheet and the a-SiO<sub>2</sub> substrate [\[22\]](#page-6-16). For the interstitial oxygen, our binding energy, and equilibrium geometry results are in agreement with the ones of the most stable configuration predicted by Ziletti et al. [\[19\]](#page-6-14).

The structural model, and the total energy differences in (i) are depicted in Figs.  $4(c) - 4(e)$  $4(c) - 4(e)$ ; by comparing the total energies, we found the latter (former) configuration as the most (less) stable one. Thus, indicating that, even at the presence of interstitial oxygen attached to the SLP, the remnant  $H$  atom from the  $H_2O$  molecule promotes the formation hydroxyls on the a-SiO<sub>2</sub> surface, Fig.  $4(e)$  $4(e)$ , as we verified on the  $a-SiO<sub>2</sub>$  pristine surface. In this case, there is an atomic rearrangement on the  $a-SiO<sub>2</sub>$  surface, in order to keep the two-fold (four-fold) coordination of the surface O (Si) atoms. However, it is worth noting that due to the amorphous character of the surface, the formation of hydroxyl groups on  $a-SiO<sub>2</sub>$  will depend on the local geometry, and thus, although energetically less stable, we may find the formation of hydroxyl groups on the SLP, as shown in Fig. [4\(](#page-4-0)d).

In (ii), we find that dissociation of  $H_2O_2$ , giving rise to hydroxyl groups attached to the  $SLP$  or a-Si $O_2$  surface, is an exothermic process. Here we have considered a number of plausible configurations of OH at the SLP−a-SiO<sup>2</sup> interface. For an OH group attached to the SLP sheet, Fig. [4\(](#page-4-0)f), we find a total energy release of  $0.99 \text{ eV}/\text{OH}$ , when compared with the separated components, namely, pristine  $SLP/a-SiO<sub>2</sub>$  and a  $H<sub>2</sub>O<sub>2</sub>$  molecule. Further total energy comparisons indicate that the SLP/(OH)a- $SiO<sub>2</sub>$  configuration [Fig. [4\(](#page-4-0)g)] is more stable by 1.13 eV. Whereas, again due to the amorphous character of the surface, we may find an energetically quite stable configuration composed by an oxygen atom (two fold coordinated) forming a P–O–Si bridge structure between the  $SLP$  and the a- $SiO<sub>2</sub>$  surface; while the remnant hydrogen atom forms an OH group with the  $a-SiO<sub>2</sub>$  surface, Fig.  $4(h)$  $4(h)$ .

X-ray absorption spectroscopy (XAS) has been considered a quite suitable technique to provide informations about atomic and electronic structure near the probed element. Here, we characterize the presence of OH groups by performing a set of XAS simulations of the oxygen K-edge spectrum in  $SLP/a-SiO<sub>2</sub>$ .

Initially, in order to verify the adequacy of our calcu-



<span id="page-4-0"></span>FIG. 4. Equilibrium geometries of H2O molecules embedded in the  $SLP/a-SiO<sub>2</sub>$  interface, undissociated (a), and dissociated formig OH groups (b). Esquibrium geometries of H2O molecules intercalated between the oxidized SLP and the a-SiO<sub>2</sub> surface, undissociated (c), dissociate forming an OH group bonded to the SLP and another bonded to the  $a-SiO<sub>2</sub>$ surface (d), and forming two OH groups bonded to the a-SiO<sub>2</sub> surface (e). Equilibrium geometry of an OH group bonded to the SLP (f), an OH group bonded to the a-SiO<sub>2</sub> (g), and an oxygen atoms forming a P–O–Si bridge structure (h). The P, O, Si and H atoms are represented by light purple, red and gray color spheres.

lation procedure, we calculated the oxygen K-edge spectrum of  $\alpha$ -quartz (SiO<sub>2</sub>). Where, as shown in Fig. [5](#page-5-0) (solid lines), we find a good agreement with the previous the-



<span id="page-5-0"></span>FIG. 5. Oxygen K-edge XANES spectrum obtained for the  $\alpha$ quartz geometry comparing with experimental and theoretical  $data[55]$  $data[55]$ .



<span id="page-5-1"></span>FIG. 6. Simulated oxygen K-edge XAS spectrum of the OH group for structural models depicted in Figs.  $4(f)$  $4(f)$ ,  $4(g)$ , and [4\(](#page-4-0)h) (a). O K-edge spectrum of the OH group of the structural models shown in Fig.  $4(f)$  $4(f)$  and  $4(g)$ . (b) at the equilibrium geometry  $(h=2.00 \text{ Å}, \text{ solid-line})$  and increasing the vertical distance  $(h=4.00 \text{ A}, \text{dashed-line})$ , and  $(c)$  at the equilibrium geometry  $(h=2.82 \text{ A}, \text{ solid-line})$  and increasing the vertical distance  $(h=6.82 \text{ A}, \text{dashed-line}).$ 

oretical/experimental findings  $[55]$ . For the  $SLP/a-SiO<sub>2</sub>$ , we examine the K-edge spectrum of the oxygen atom of the OH group, as shown in Figs.  $4(f)$  $4(f)$  and  $4(g)$ , as well as

the one forming the P-O-Si bridge structure presented in Fig.  $4(h)$  $4(h)$ . Based on the PDOS results, shown in Fig.  $2(a)$  $2(a)$ , the final state in the O-1s  $\rightarrow p$  transition should present a dominant contribution from the P-3p orbitals of the SLP; even upon the presence of a core hole in the (probed) oxygen atom. Thus, suggesting a weak dependence between the O K-edge energy position and the configuration of the oxygen atom in  $SLP/a-SiO_2$ . Indeed, for the three structural models, the XAS spectra present somewhat the same feature, with the O-1s peak lying within the shaded region in Fig. $6(a)$ . Indicated by arrows in Fig.  $6(a)$  $6(a)$ , we verify that the O-1s peak is more intense for OH group bonded to the SLP [structural model shown in Fig. [4\(](#page-4-0)f)], and less intense for OH bonded to the  $SiO<sub>2</sub>$ surface  $[Fig. 4(g)]$  $[Fig. 4(g)]$  $[Fig. 4(g)]$ . Meanwhile, for O atom forming the P-O-Si bridge structure, Fig.  $4(h)$  $4(h)$ , we have an intermediate intensity.

Computational simulations can be a quite useful tool to help the interpretation of XAS spectra. For instance, we can simulate a set of configurations, which are experimentally non-accessible, aiming to provide additional informations of a given spectrum. In Fig.  $6(b)$  $6(b)$ , the solid line indicate the original O K-edge spectrum of OH bonded to the SLP [Fig.  $4(f)$  $4(f)$ ]; while the dashed line corresponds to the O K-edge spectrum of the same OH configuration, but increasing the vertical distance (h) from  $2.00 \text{ Å}$  (equilibrium geometry) to  $4.00 \text{ Å}$ . In this case, the role played by the  $a-SiO<sub>2</sub>$  surface, to the XAS spectrum, has been reduced. We find that the two (original)  $O-1s$ peaks reduce to a single one with higher intensity. Thus, indicating that (i) the  $a-SiO<sub>2</sub>$  surface orbitals contribute to the final state of O K-edge spectrum of OH bonded to the SLP, and (ii) the interaction with the  $a-SiO<sub>2</sub>$  surface reduces the O-1s binding energy. On the other hand, for OH group bonded to the a-SiO<sub>2</sub> surface [Fig. [4\(](#page-4-0)g)], (i) the feature indicated by an arrow in Fig.  $6(c)$  $6(c)$  has been suppressed by increasing the vertical distance,  $h = 2.82$ (equilibrium position)  $\rightarrow 6.82 \text{ Å}$ , and (ii) there is an increase on the O-1s binding energy. Those results can be attributed to the reduction of electronic contributions from the phosphorene to the final state of O K-edge spectrum.

#### IV. SUMMARY

In summary, based on first-principles calculations we investigate (i) the electronic and structural properties of a single layer phosphorene (SLP) adsorbed on the amorphous silicon oxide surface  $(SLP/a-SiO<sub>2</sub>)$ , and (ii) the incorporation of  $H_2O$  molecules in the  $SLP-a-SiO_2$  interface. In (i), we find that single layer phosphorene bonds to the amorphous  $SiO_2$  surface  $(SLP/a-SiO_2)$  mediated by vdW interactions. There are no chemical bonds between the SLP and the surface, even at the presence of oxygen vacancies  $(V<sub>O</sub>)$ , which is a common intrinsic defect in  $a-SiO_2$ . The (amorphous) surface corrugation promotes a non-uniform charge density distribution, giving rise to electron-hole puddles in  $SLP/a-SiO_2$ . Such charge density puddles are strengthened upon the presence of  $V_O$ , which may reduce the carrier mobility in the phosphorene layer. The  $V_O$  defect gives rise to an occupied level in the band gap of  $a-SiO<sub>2</sub>$ ; upon the formation of  $SLP/a-SiO<sub>2</sub>$ , the defect level lies near the valence band maximum of the SLP. We estimate the band alignment of  $SLP/a-SiO_2$ , where we find a type-I band offset. In (ii), we find an energetic preference for the formation of hydroxyl (OH) groups bonded to the pristine  $a-SiO<sub>2</sub>$  surface, as well as upon the presence of the SLP,  $SLP/a-SiO<sub>2</sub>$ . However, due to the amorphous structure of the surface, depending on the local geometry, we may find other energetically stable configurations. Indeed, we found one composed by an hydrogen atom bonded to the a-SiO<sub>2</sub> surface and the oxygen atom forming a P–O–Si bridge structure. Further x-ray absorption spectroscopy (XAS) simulations, of oxygen atom forming OH or P– O–Si bridge structure, reveal that the K-edge spectra present different features for each configuration.

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